

Form PTO-1449 (modified)	Atty. Docket No.: ASGR:002USD1	Serial No.: 10/052,771
List of Patents and Publications for Applicant's INFORMATION DISCLOSURE STATEMENT (Use several sheets if necessary)	Applicant: Schillinger et al.	
	Filing Date: January 23, 2002	Group: 1661
U.S. Patent Documents <i>See Page 1</i>	Foreign Patent Documents <i>See Page 1</i>	Other Art <i>See Page 1</i>

U.S. Patent Documents

Exam. Init.	Ref. Des.	Document Number	Date	Name	Class	Sub Class	Filing Date of App.
/A.P./	A9	2002/112260	08/15/02	Schillinger <i>et al.</i>	430	45.2	01/23/02
/A.P./	A10	5,141,870	08/25/92	Bedbrook <i>et al.</i>	435	320.1	01/18/91
/A.P./	A11	5,188,642	02/23/93	Shah <i>et al.</i>	47	58.1R	02/12/90
/A.P./	A12	5,312,910	05/17/94	Kishore <i>et al.</i>	536	23.2	09/04/92
/A.P./	A13	5,599,769	02/04/97	Hacker <i>et al.</i>	504	128	06/05/95
/A.P./	A14	5,633,435	05/27/97	Barry <i>et al.</i>	800	288	09/13/94
/A.P./	A15	6,376,754	04/23/02	Schillinger <i>et al.</i>	800	312	03/07/97

Foreign Patent Documents

Exam. Init.	Ref. Des.	Document Number	Date	Country	Language
/A.P./	B2	2,283,460	03/05/98	Canada	English
/A.P./	B3	EP 0 430 511	11/16/90	Europe	English
/A.P./	B4	WO 87/06606	04/21/87	PCT	English
/A.P./	B5	WO 98/39419	09/11/98	PCT	English

Other Art (Including Author, Title, Date Pertinent Pages, Etc.)

Exam. Init.	Ref. Des.	Citation
/A.P./	C2	Office Action regarding Application No. 11/482,859, April 9, 2007.
/A.P./	C3	Neve, "Multiple herbicide resistance in a glyphosate-resistant rigid ryegrass (<i>Lolium rigidum</i>) population, <i>Weed Science</i> , 52(6):920-928, 2004 (Abstract only)
/A.P./	C4	Wilson <i>et al.</i> , "Weed Management in Onion Grown for Dehydration," <i>Commercial Horticulture Newsletter</i> , January - February 1997.
/A.P./	C5	Wilcox <i>et al.</i> , "Backcrossing high seed protein to a soybean cultivar," <i>Crop Sci.</i> , 35:1036-1041, 1995

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DATE CONSIDERED: 08/27/2007

EXAMINER: INITIAL IF REFERENCE CONSIDERED, WHETHER OR NOT CITATION IS IN CONFORMANCE WITH MPEP609; DRAW LINE THROUGH CITATION IF NOT IN CONFORMANCE AND NOT CONSIDERED. INCLUDE COPY OF THIS FORM WITH NEXT COMMUNICATION TO APPLICANT.

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Exam. Init.	Ref. Des.	Citation
/A.P./	C6	Hanson <i>et al.</i> , "Genetic analysis of energy production in soybean," <i>Crop Sci.</i> , 1:121-126, 1998.
/A.P./	C7	Openshaw <i>et al.</i> , "Selection indexes to modify protein concentration of soybean seeds," <i>Crop Sci.</i> , 24(1):1-4, 1984.
/A.P./	C8	Shankle <i>et al.</i> , "Weed management using liberty-link technology," <i>Weed Sci. Soc. Am.</i> , 37,88, 1997. (Abstract)
/A.P./	C9	"Possible pleiotropic effects in herbicide-resistant crops," In: <i>Herbicide Resistant Crops: Agricultural, Environmental, Regulatory, and Technical Aspects</i> , Duke (Ed.), Lewis Publishers, CRC Press, Inc., Boca Raton, Florida, pp. 201-210, 1996.
/A.P./	C10	Schell <i>et al.</i> , "Ti plasmids as experimental gene vectors for plants," <i>Advances in Gene Technology: Molecular Genetics of Plants and Animals</i> , Miami Winter Symposia, Miami, Florida, 20:191-209, 1993.
/A.P./	C11	Lee <i>et al.</i> , "The molecular basis of sulfonylurea herbicide resistance in tobacco," <i>EMBO J.</i> , 7:1241-1248, 1998.
/A.P./	C12	Restriction Requirement regarding Application No. 08/813,788, October 2, 1998.
/A.P./	C13	Response to Restriction Requirement regarding Application No. 08/813,788, October 26, 1998.
/A.P./	C14	Restriction Requirement regarding Application No. 08/813,788, April 14, 1999.
/A.P./	C15	Response to Restriction Requirement regarding Application No. 08/813,788, May 3, 1999.
/A.P./	C16	Office Action regarding Application No. 08/813,788, July 21, 1999.
/A.P./	C17	Amendment and Response to Office Action regarding Application No. 08/813,788, December 21, 1999.
/A.P./	C18	Final Office Action regarding Application No. 08/813,788, March 28, 2000.
/A.P./	C19	Interview Summary regarding Application No. 08/813,788, July 11, 2000.
/A.P./	C20	Preliminary Amendment regarding Application No. 08/813,788,, July 27, 2000.
/A.P./	C21	Office Action regarding Application No. 08/813,788, October 11, 2000.
/A.P./	C22	Response to Restriction Requirement regarding Application No. 08/813,788, November 13, 2000.

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Exam. Init.	Ref. Des.	Citation
/A.P./	C23	Office Action regarding Application No. 08/813,788, January 31, 2001.
/A.P./	C24	Interview Summary regarding Application No. 08/813,788, June 27, 2001.
/A.P./	C25	Amendment and Response to Office Action regarding Application No. 08/813,788, July 2, 2001.

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